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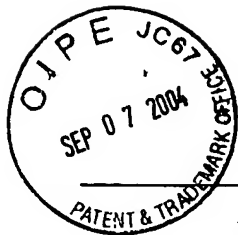
<b>TRANSMITTAL FORM</b> <i>(to be used for all correspondence after initial filing)</i>	<b>Application Number</b>	10/784,606	
	<b>Filing Date</b>	February 23, 2004	
	<b>First Named Inventor</b>	Frank DiMeo, Jr.	
	<b>Group Art Unit</b>	2856	
	<b>Examiner Name</b>	TBA	
<b>Total Number of Pages in This Submission</b>		<b>Attorney Docket Number</b>	ATMI-546-CIP-I

ENCLOSURES (check all that apply)		
<input type="checkbox"/> Fee Transmittal Form	<input type="checkbox"/> Assignment Papers (for an Application)	<input type="checkbox"/> After Allowance Communication to Group
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SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT	
<b>Firm or Individual name</b>	Margaret Chappuis, Reg. No. 45,735
<b>Signature</b>	
<b>Date</b>	August 31, 2004

CERTIFICATE OF MAILING	
I hereby certify that this correspondence is being deposited pursuant to 37 C.F.R. 1.8 in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this date: 9-2-04	
<b>Type or printed name</b>	Lee Ann DiLello
<b>Signature</b>	
<b>Date</b>	9-2-04

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ATMI-546-CIP-I  
Customer ID No.: 25559

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Frank DiMeo, Jr.

Group Art Unit: 2856

U.S. Application No.: 10/784,606

Examiner: TBA

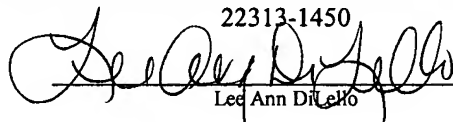
Filed: February 23, 2004

Title: NICKEL-COATED FREE-STANDING SILICON CARBIDE STRUCTURE FOR  
SENSING FLUORO OR HALOGEN SPECIES IN SEMICONDUCTOR PROCESSING  
SYSTEMS, AND PROCESSES OF MAKING AND USING SAME

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Lee Ann DiLello  
9-2-04  
Date

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required in accordance with 37 CFR § 1.56 and § 1.97(b). Please note that Reference AH "Inorganic Solid Fluorides, Chemistry and Physics" is a book and

is not enclosed. Should a copy of this reference be required, Applicants will provide a copy.

- ☐ 2. This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.
  - ☐ a. I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of such item by a foreign patent office in a counterpart foreign application, which occurred no more than three months prior to filing the Information Disclosure Statement. 37 C.F.R. §1.97(e)(1).
  - ☐ b. I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. §1.97(e)(2).
  - ☐ c. Attached is our check no. \_\_\_\_ in the amount of \$180 in payment of the fee under 37 C.F.R. §1.17(p). Please credit or debit Deposit Account No. 50-0860 as needed to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.
- ☐ 3. This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee. Applicant(s) hereby petition(s) that the Information Disclosure Statement be considered. Attached is our check no. \_\_\_\_ in the amount of \$130.00 in payment of the petition fee under 37 C.F.R. §1.17(i)(1). Please credit or debit Deposit Account No. \_\_\_\_ as needed to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.
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  - ☐ b. I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. §1.97(e)(2).
- ☐ 4. (other):

Applicant does not believe that any additional fee is due in connection with the foregoing. However, any deficiencies may be charged to the deposit account 50-0860.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Margaret Chappuis".

Margaret Chappuis  
Registration No. 45,735  
Agent for Applicant

Date: *August 31, 2004*  
Advanced Technology Materials, Inc.  
7 Commerce Drive  
Danbury, CT 06810  
Agent Ref: ATMI-546-CIP-I



FORM PTO-949 SEP 07 2004 INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)	US Dept. of Commerce Patent and Trademark Office	ATTORNEY DOCKET NO. ATMI-546-CIP-I	SERIAL NO. 10/784,606
	APPLICANT Frank DiMeo, Jr.		
	FILING DATE February 23, 2004	GROUP 2856	

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	10/273,036	10/17/2002	Frank DiMeo, Jr., et al.			
	AB	6,265,222	6/24/2001	Frank DiMeo, Jr., et al.			
	AC	5,679,576 A	10/21/1997	Kawai, et al.			
	AD	5,612,489 A	3/18/1997	Ragsdale, et al.			
	AE	6,428,713 B1	8/6/2002	Christenson, et al.			
	AF	4,723,438 A	2/9/1988	Adler-Golden, et al.			

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES	NO
							X (abstract only)	

## OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)

	AG	Anderson, B, et al., Semiconductor International, October (1993)
	AH	Inorganic Solid Fluorides, Chemistry and Physics, Academic Press, 1985, Ed P. Hagenmuller. (See Information Disclosure Statement Box 1)
	AI	W. Moritz, et al., Sensors and Actuators B 24-25 (1995) 194-196, "Monitoring of HF and F2 using a field-effect sensor"
	AJ	Dr. Shigeru Kurosawa, et al., Fluorine in Coatings II, Paper 33, pgs. 1-8, "Plasma Polymerisation of Fluorine Contained Polycyclic Compounds: Its Application in Chemical Sensors"
	AK	Werner Moritz, et al., The 11th European Conference on Solid State Transducers, Warsaw, Poland, pgs. 111-114, September 21-24, 1997, "Gas Sensors for Fluorine Using Different Semiconductor Substrates"
	AL	W. Moritz, et al., 1998 American Chemical Society, Chapter 10, pgs. 119-129, "Silicon-Based Sensor for Fluorine Gas"
	AM	Semiconductor International, "Residual Gas Analysis", Oct. 1997, pgs. 94-100

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EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	